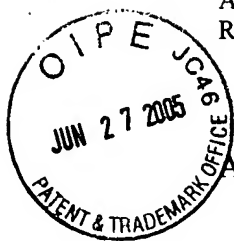


Application No. 10/750,054
Amendment filed: June 23, 2005
Reply to Office Action of March 23, 2005



Attorney's Docket No.: 042390.P16676

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Steven Keating

Application No.: 10/750,054

Filed: December 30, 2003

For: AN AMORPHOUS ETCH STOP FOR
THE ANISOTROPIC ETCHING OF
SUBSTRATES

Examiner: Dang, Trung Q

Art Unit: 2823

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Office Action mailed March 23, 2003. Applicant respectfully requests the Examiner to consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 6/23/05

Date of Deposit

Vanessa Sanchez

Name of Person Mailing Correspondence

Vanessa Sanchez
Signature

6/23/05
Date